

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshitsugu MORITA et al.

Int. App. Serial No.: PCT/JP2004/018548

Group Art Unit: Unknown

Atty. No. : 71,051-035

Examiner: Unknown

Filed : Herewith

Title : SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THEREOF

PRELIMINARY AMENDMENT

MAIL STOP PCT

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Dear Sir:

In reference to the above-referenced patent application, please enter the following Preliminary Amendment and consider the accompanying remarks prior to examination on the merits. A complete listing of all claims pending in the application is included as required under 37 CFR § 1.121.